

Docket No.: 061282-0055

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Takeshi KOBAYASHI, et al. : Confirmation Number: 4950
Application No.: 10/757,388 : Group Art Unit: 2814
Filed: January 15, 2004 : Examiner: Dilinh P. Nguyen

For: LEAD FRAME, METHOD OF MANUFACTURING THE SAME, SEMICONDUCTOR DEVICE USING LEAD FRAME AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☒ Also attached: Copy of Figures 9A-9D, 10, and U.S. Patent No. 5,900,676.

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	31	31	0	\$50.00 =	\$0.00
Independent Claims	4	4	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

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WDC99 1198563-1.061282.0055

Please recognize our Customer No. 20277 as our correspondence address.



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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

In re Application of	:	Customer Number: 20277
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Takeshi KOBAYASHI, et al.	:	Confirmation Number: 4950
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Application No.: 10/757,388	:	Group Art Unit: 2814
	:	
Filed: January 15, 2004	:	Examiner: Dilinh P. Nguyen
	:	

For: LEAD FRAME, METHOD OF MANUFACTURING THE SAME, SEMICONDUCTOR
DEVICE USING LEAD FRAME AND METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 30, 2005, having a three-month shortened statutory period for response set to expire on February 28, 2006, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.